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# Noise-robust online measurement of the on-state resistance of the power semiconductor devices in PWM converters

Junho Shin<sup>1</sup>, Jong-Won Shin<sup>2</sup>, and Wonhee Kim<sup>3</sup>

<sup>1</sup>Department of Smart Cities, Chung-Ang University, Seoul, Korea

<sup>2</sup>Department of Electrical and Computer Engineering, Seoul National University, Seoul, Korea

<sup>3</sup>The School of Energy Systems Engineering, Chung-Ang University, Seoul, Korea

Corresponding author: Jong-Won Shin (e-mail: jongwonshin@snu.ac.kr).

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**ABSTRACT** The on-state resistance of power semiconductor devices,  $R_{DUT}$ , is used to estimate the remaining useful life (RUL) of the devices. Conventional online measurement of  $R_{DUT}$  involves on-state voltage measurement of the on-state device, which is easily polluted by switching noise to limit the measurement accuracy. This paper proposes a new noise-robust method to measure the increment of  $R_{DUT}$  by inductor current and input/output DC voltage of DC-DC converters. The proposed method features higher accuracy in predicting RUL than the conventional one because the inductor current is immune to switching noise. Experimental results showed 99.2% maximum accuracy between the actual and measured  $R_{DUT}$  of sample MOSFETs.

**INDEX TERMS** On-state resistance, remaining useful life (RUL), online monitoring, power semiconductor devices.

## I. INTRODUCTION

Power semiconductor devices such as metal oxide semiconductor field effect transistors (MOSFETs), insulated gate bipolar transistors (IGBTs), and diodes are identified as the most failure-prone components in power conversion systems [1]-[2]. Studies have been conducted to estimate the RUL of power semiconductors in power conversion system (PCS) such as inverters and to use different control methods to increase the RUL [3]. As such, predicting the remaining useful life (RUL) of these devices is critical for avoiding failures and improving reliability of the PCS. The failures of power semiconductors have been analyzed and their predictive models have been studied to forecast the RUL [2]. The aging of IGBTs is predicted by changes in resonance characteristics [4] and gate-source voltage waveforms [5] in their off-state. This method does not require measuring other

parameters, such as the current flowing through the power semiconductors, to determine aging. Estimating RUL from the changes in resonance and gate-source waveforms has disadvantage of requiring human verification with an instrument such as an oscilloscope.

The RUL of the power semiconductor devices is generally represented by their on-state resistances  $R_{DUT}$ , because the bond wires inside the package are gradually lifted off or cracked as they age [6]-[14]. One of the simplest ways to measure  $R_{DUT}$  is to use a multimeter or milli-ohm meter which is widely utilized to measure resistances. These meters, however, are not applicable to online measurement, i.e., measuring  $R_{DUT}$  while PCS is processing power, since they may be damaged by the high voltages and currents. Also, typical duration of the ON state of power semiconductor devices a few or a few tens of microseconds. The meters

cannot measure  $R_{DUT}$  in this short interval due to their limited bandwidth. In addition, multimeters and milli-ohm meters measure the absolute value of the resistance, while the proposed method detects the increase in resistance – this point will be discussed in detail in the rest of the paper.

Digital twin method analyzes the voltage and current dynamics of the operating PCS in real time [15], and is applicable to estimate the change in  $R_{DUT}$ . This approach is capable of observing multiple quantities simultaneously. However, the digital twin method may not be cost-effective compared to the circuit-based approach since it requires many sensors, high-rate data sampling which is higher enough than the switching frequency of PCS, and substantial computational resources.

A typical method of measuring  $R_{DUT}$  during the PCS operation is to sense the on-state voltage and on-state current of the power semiconductor device to calculate  $R_{DUT}$ . Fig. 1 represents the concept of conventional on-state voltage measurement circuit (OVMC) with a MOSFET as DUT (device under test). The OVMC measures the drain-source voltage of the DUT,  $v_{ds}$ , to estimate its RUL. The output voltage of the OVMC  $v_{out}$  is expressed as (1)

$$v_{out} = k_v (v_{ds} + v_n) \quad (1)$$

where  $k_v$  represents the total sensing gain of the OVMC and analog-to-digital (ADC) converter of microcontroller unit (MCU). Voltage  $v_n$  is the error by the switching noise which degrades the accuracy of the monitoring  $R_{DUT}$ . The output of the current sensor  $i_{out}$  is defined similarly as in (2).

$$i_{out} = k_i (i_{ds} + i_n) \quad (2)$$

In (2),  $k_i$ ,  $i_{ds}$ , and  $i_n$  are the total sensing gain of the current sensor and the ADC, current flowing through the DUT, and current error by the switching noise. Because the current is generally less susceptible to the noise compared to the voltage,  $i_n$  is assumed zero or  $i_n \approx 0$ . Ohm's law provides the relationship between  $i_{ds}$ ,  $v_{ds}$ , and  $R_{DUT}$  as in (3).

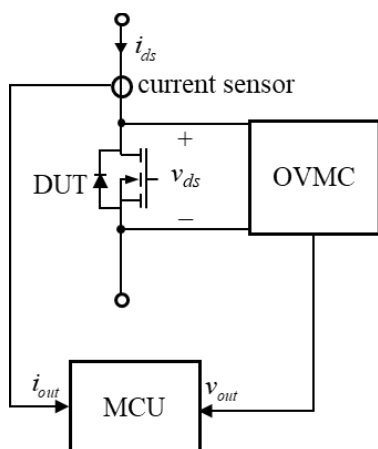


FIGURE 1. Conventional OVMC with a MOSFET as a DUT.

$$v_{ds} = i_{ds} R_{DUT} \quad (3)$$

Substituting (1) and (2) into (3) yields the expression of  $R_{DUT}$  in (4).

$$R_{DUT} = \frac{k_i}{k_v} \left( \frac{v_{out}}{i_{out}} \right) - \left( \frac{k_i}{i_{out}} \right) v_n \quad (4)$$

One representative drawback of the conventional OVMCs is that monitoring  $v_{ds}$  is highly prone to switching noise, i.e.,  $v_n$  in (1) and (4) is not negligible. Since the MCU realizes the calculation of the right-hand side in (4) without filtering or correcting  $v_n$ ,  $v_n$  distorts the value of  $R_{DUT}$  and thus degrades the accuracy of estimating the RUL of the DUT.

This paper proposes the monitoring technique of  $R_{DUT}$  of the working MOSFET without sensing or measuring the noise-sensitive  $v_{ds}$  [27]. This enhances the noise robustness of the estimation of RUL and simplifies the structure of the sensing circuit. Section II introduces the traditional OVMC structures and the limitations of conventional on-state resistance measurement methods. A comparison between the conventional OVMCs and the proposed method is explained in detail in Section III. The experimental setups and results are shown in Section IV, and the conclusion is discussed in Section V.

## II. LIMITATION OF CONVENTIONAL ON-STATE RESISTANCE MEASUREMENT METHODS

Conventional OVMCs can be categorized into two: the one is to use diode clamp circuits [18]-[26], and the other is to utilize MOSFET clamp circuits [9]-[11], [16]-[17]. The diode clamp circuits are again divided into two groups: the one using single diode [18]-[20], and the other using two series-connected diodes [21]-[26]. This categorization is based on the number of forward-biased diodes excluding Zener diodes when the power semiconductor device is ON. The single diode clamping circuits sense on-state current. Circuit in [19] senses voltage across a resistor which is series-connected in the on-state current path. Circuits in [18], [20]-[21] detects the voltage across gallium nitride transistors. A clamp circuit using two diodes is used to analyze the aging of power semiconductors by power cycle [22] and thermal cycle [23]. The loss breakdown models and a calorimetric switching loss measurement method utilizing a two-diodes clamp circuit are presented in [25]. The simple OVMC using protection diode only [26] is free from the errors induced by diode, while its usage is limited from high-voltage applications.

Fig. 2(a) shows the representative single diode clamp circuit. Literals  $v_{gs}$ ,  $v_{ds}$ , and  $i_{ds}$  are the gate-source voltage, drain-source voltage, and drain-source current of the DUT, respectively. This circuit has been widely used to sense the on-state current of MOSFETs or IGBTs since its simple

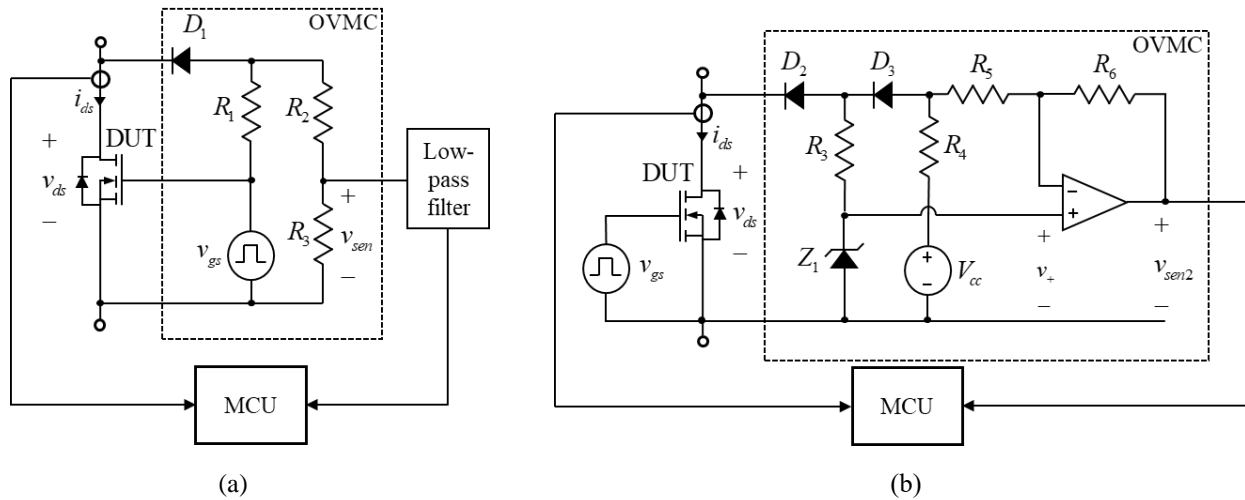


FIGURE 2. Conventional OVMCs based on (a) single clamp diode and (b) two diodes.

structure without extra voltage source [28]. Utilizing the output voltage of the OVMC,  $v_{sen}$ , the estimation of the RUL was conducted as well [29]. The operation is as follows: clamp diode  $D_1$  turns on when  $v_{gs}$  is greater than  $v_{ds}$ , i.e., when the DUT is on. The voltage  $v_{sen}$  is given by (5) neglecting the switching noise.

$$v_{sen} = \frac{R_3}{R_3 + R_2} (v_{ds} + v_{D1}) \quad (5)$$

In (5),  $v_{D1}$  is the forward voltage drop of  $D_1$  that makes the relationship between  $v_{sen}$  and  $v_{ds}$  nonlinear. Assuming the sensing gain of  $i_{ds}$  is unity or  $i_{out} = i_{ds}$ ,  $R_{DUT}$  is expressed in terms of  $v_{sen}$  as in (6).

$$R_{DUT} = \frac{v_{ds}}{i_{ds}} = \frac{R_3 + R_2}{R_3} \left( \frac{v_{sen}}{i_{out}} \right) - \frac{v_{D1}}{i_{out}} \quad (6)$$

Fig. 3 shows the experimental waveform of the OVMC circuit in Fig. 2(a). Green voltage waveform  $v_R$  with 900 mV/div. scale represents the current  $i_{ds}$  measured by a 0.3- $\Omega$  shunt resistance. Magenta and blue waveforms represent  $v_{sen}$  (200 mV/div.) and  $v_{gs}$  (10 V/div.), respectively. The thick

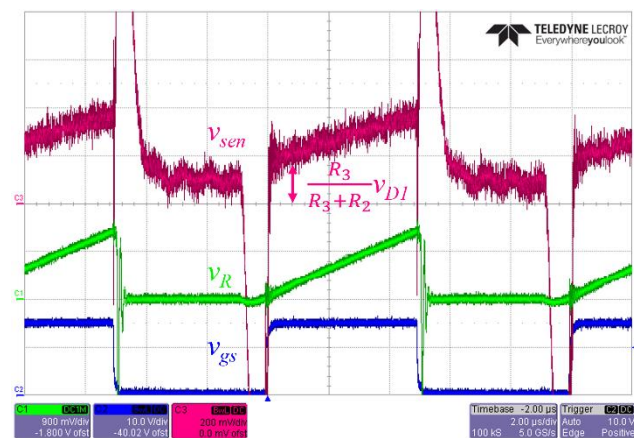


FIGURE 3. OVMC experimental waveform with a single clamp diode.

waveform of  $v_{sen}$  during the ON state of DUT indicates its low signal-to-noise ratio. Substantial distortion also occurs during the turn-off transient. The DC component of  $v_{sen}$ ,

$$\frac{R_3}{R_3 + R_2} v_{D1}$$

was generated by the forward voltage drop of  $D_1$  as explained in (5). These may result in less accurate  $R_{DUT}$  measurements, and a filter is required to attenuate these distortions. This filter complicates the design procedure and increases the circuit complexity. Even assuming  $v_{sen}$  is unaffected by the switching noise, (6) reveals that the accurate estimation of  $R_{DUT}$  is difficult by two factors,  $v_{D1}$  and  $i_{out}$ . The voltage  $v_{D1}$  varies by various factors such as the current and temperature of  $D_1$ , and utilizing its exact value is not straightforward. And division by  $i_{out}$  in (6) requires considerable resource in MCU.

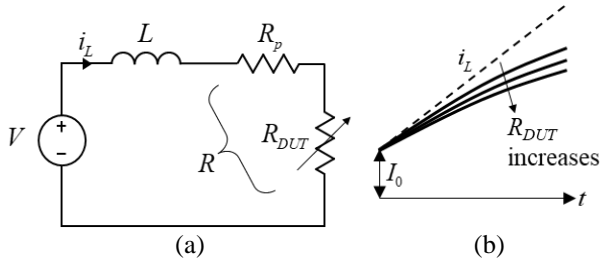
Fig. 2(b) shows another OVMC with extra voltage source  $V_{cc}$  [25]. Literals  $v_{sen2}$  and  $V_{cc}$  represent the output of the OVMC and external DC voltage source, respectively. Diodes  $D_2$  and  $D_3$  turn on when  $V_{cc}$  is greater than  $v_{ds}$ . The positive input voltage of operation amplifier (op-amp),  $v_+$ , is equal to  $v_{ds}$  plus the forward voltage drop of  $D_2$ ,  $v_{D2}$ . During the on-state of the DUT,  $v_{sen2}$  is expressed as (7).

$$\begin{aligned} v_{sen2} &= v_+ + \frac{R_6}{R_5} [v_+ - (v_{ds} + v_{D2} + v_{D3})] \\ &= v_{ds} + v_{D2} - \frac{R_6}{R_5} v_{D3} \end{aligned} \quad (7)$$

In (7),  $v_{D3}$  represents the forward voltage drop of  $D_3$ , and  $R_5$  and  $R_6$  are resistors connected to the op-amp. The forward voltage drops cancel out each other by designing

$$v_{D2} = \frac{R_6}{R_5} v_{D3}$$

Typically,  $D_1$  and  $D_2$  are similar devices and  $R_5$  and  $R_6$  have equal resistances. Then  $R_{DUT}$  is simply expressed as shown in (8) assuming  $i_{out} = i_{ds}$ .



**FIGURE 4.** (a) Equivalent circuit of PWM converters when DUT is on. (b) Exponential waveshape of  $i_L$  by parasitic series resistances when inductor store energy.

$$R_{DUT} = \frac{v_{ds}}{i_{out}} = \frac{v_{sen2}}{i_{out}} \quad (8)$$

In practice, capacitors are added around the op-amp to form a low-pass filter and suppress the high-frequency noise in  $v_+$ . The increased components count is also a drawback of the OVMC in Fig. 2(b).

### III. PROPOSED METHOD FOR MEASURING THE INCREASE OF THE ON-STATE RESISTANCE

The RUL of a MOSFET is estimated by  $R_{DUT}$  as explained in Section II. The key idea of this paper is that the RUL estimation does not necessarily require the absolute value of  $R_{DUT}$  – only the *increment* of  $R_{DUT}$  over time suffices. The increasing trend of the resistance is estimated using Gaussian process regression, the extended Kalman filter, and the particle filter [13]. The DUT is considered expired when its  $R_{DUT}$  undergoes a 20% increase relative to its initial value [30]. The proposed method measures the increment of  $R_{DUT}$  using the inductor current information sensed by a simple circuit in pulse-width-modulated (PWM) converters.

In PWM converters, inductors store energy when its current increases, and releases the energy when the current decreases. A PWM converter when DUT is on is simplified into the equivalent circuit shown in Fig. 4(a) where  $i_L$  and  $V$  are the inductor current and equivalent voltage across the inductor. The current  $i_L$  will increase if  $V$  is positive or will decrease if  $V$  is negative. Literal  $L$  is the inductance of the inductor and  $R_p$  represents the lumped parasitic resistance in

conduction path of  $i_L$  including copper trace resistance of printed circuit board, equivalent series resistance of the inductor, etc. The resistance  $R_p$  is assumed to be fixed throughout the operation, i.e.,  $R_p$  is not affected by RUL. The slope of  $i_L$  is assumed constant in typical analysis of the converters as shown by the dashed line in Fig. 4(b) because  $R_p$  and  $R_{DUT}$  are assumed negligibly small. When the sum of  $R_p$  and  $R_{DUT}$ , or  $R$ , is not zero,  $i_L$  becomes exponential as expressed by the solid lines in Fig. 4(b) and (9).

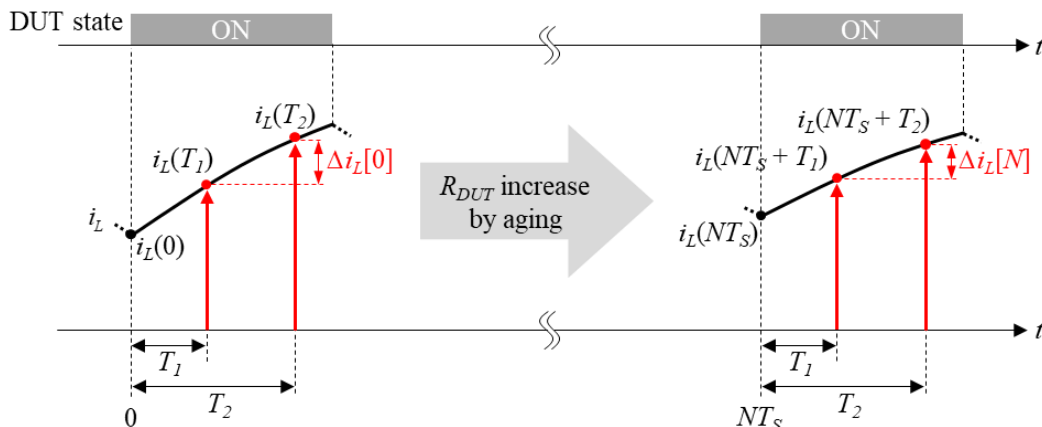
$$i_L(t) = \frac{V}{R} - \left( \frac{V}{R} - I_0 \right) e^{-\frac{R}{L}t} \quad (9)$$

Current  $I_0$  in (9) and Fig. 4(b) is the initial  $i_L$  of the on-state interval. The ripple of this exponential  $i_L$  decreases as  $R_{DUT}$  increases by the aging of the DUT as depicted by the solid lines in Fig. 4(b). The proposed method measures this difference to estimate the RUL of the DUT.

Fig. 5 elaborates the measurement of the ripple of  $i_L$ . At the first turn-on interval which starts at time  $t = 0$ , the DUT is assumed fresh and its  $R_{DUT}$  is small. The current  $i_L$  is sampled by the MCU at two instants  $T_1$  and  $T_2$  as  $i_L(T_1)$  and  $i_L(T_2)$ , respectively, while the DUT is on. Equation (10) shows  $\Delta i_L[k]$  as the difference between the two sampled values in  $k$ -th switching cycle.

$$\begin{aligned} \Delta i_L[k] &= \left| i_L(kT_S + T_1) - i_L(kT_S + T_2) \right| \\ &= \left| \left( \frac{V}{R} - i_L(kT_S) \right) \left( e^{-\frac{R}{L}T_1} - e^{-\frac{R}{L}T_2} \right) \right| \end{aligned} \quad (10)$$

In (10),  $V$  and  $L$  are assumed to be constant within a switching cycle. The variation of  $R$  within a switching cycle is also assumed to be negligible although it increases due to the aging of DUT over time. The sampling time instants  $T_1$  and  $T_2$  are fixed throughout the operation of the converter to simplify the calculation and save resources in MCU. Fixing  $T_1$  and  $T_2$  also prevents other effects on the measurement such as dead time between MOSFETs. If  $R$  is numerically smaller enough than  $V$ , which is generally the case, approximation in (11) simplifies (10) into (12).



**FIGURE 5.** Decreasing ripple of  $i_L$  as  $R_{DUT}$  increases by the aging of DUT.

TABLE I CURRENT PATHS,  $V$ , AND  $R$  OF THE EQUIVALENT CIRCUIT IN FIG. 3 IN SEVERAL PWM DC-DC CONVERTERS

Topology	Inductor current path with MOSETs ON (red) Inductor current path with MOSFETs OFF (blue)	$V$ in Fig. 4(a)		$R$ in Fig. 4(a)	
		MOSFETs ON	MOSFETs OFF	MOSFETs ON	MOSFETs OFF
Buck		$V_g - V_o$	$-V_o$	$R_{DUT1} + R_p$	$R_{DUT2} + R_p$
Boost		$V_g$	$V_g - V_o$	$R_{DUT1} + R_p$	$R_{DUT2} + R_p$
Noninverting buck-boost		$V_g$	$-V_o$	$R_{DUT1} + R_{DUT4} + R_p$	$R_{DUT2} + R_{DUT3} + R_p$

$$\frac{V}{R} \gg i_L (kT_S) \quad (11)$$

$$\Delta i_L [k] \cong \frac{V}{R} \left| e^{-\frac{R}{L}T_1} - e^{-\frac{R}{L}T_2} \right| \quad (12)$$

The difference  $\Delta i_L$  will decrease as  $R$  increases according to (12), or  $\Delta i_L [O] > \Delta i_L [N]$  as shown in Fig. 5. The MCU can judge if the DUT is expired when  $\Delta i_L$  calculated by (12) becomes smaller than a certain preset value.

The proposed method has several advantages over the conventional methods. One of these advantages is that the method is more noise-robust than the conventional OVMC's explained in Section II. Literals  $V$  and  $i_L$  in (12), which should be sensed to calculate  $R_{DUT}$ , are less prone to the switching noise than the on-state voltage of the DUT such as  $v_{ds}$  in Fig. 2. These values do not need additional sensing or detection circuit because they are typically already sensed for system control purposes. The noise-robustness of the proposed method simplifies or even eliminates the low-pass filter in Fig. 2 and improves the accuracy of the estimation of the RUL.

The method is also applicable to various power conversion topologies and operation modes. Table I shows several DC-DC converters with inductor  $L$ . They are powered by a voltage

source  $V_g$  to generate output voltage  $V_o$ . Red arrows indicate the path of  $i_L$  assuming the MOSFETs are on. The on-state  $V$ 's and  $R$ 's of the equivalent circuit in Fig. 4(a) and (12) for each converter are listed in Table I.

The explanations so far have focused on the intervals in which  $i_L$  increases. It should be mentioned that the proposed method is also applicable to the intervals where  $i_L$  decreases. The on-state resistance of the devices in the freewheeling paths, indicated by the blue arrows in Table I, can also be measured. Equations (9), (10), and (12) and inequality (11) hold the same in these cases except that  $V$  is negative.

The proposed method also works in the PWM converters operating in discontinuous conduction mode. The current  $i_L$  is zero at the beginning of each switching cycle, i.e.,  $i_L(kT_S) = 0$ . The semi-equal sign in (12) is replaced by an equal sign in this case.

## IV. EXPERIMENTS

### A. HARDWARE SETUP

The experiments verify the proposed method in a non-inverting buck-boost converter of which input and output are the same. Figs. 6 and 7(a) show the photograph of the prototype converter and the experimental setup around it, respectively. In Fig. 7(a),  $V_g$  is the input voltage, and  $v_{gs}$  is the gate signal for both MOSFETs  $Q$  and DUT. Resistor  $R_{ext}$





TABLE II PARAMETERS OF EXPERIMENT CIRCUIT

Parameter	Description
$V_g$	10 V
$L$	10 $\mu$ H
$Q$ and DUT	STW58N60DM2AG, FQA28N15, C3M0120090D, or IMW120R350M1H
Switching frequency	100 kHz
$D_1$ and $D_2$	APT30S20BG
$R_{shunt}$	0.3 $\Omega$
$R_{ext}$ (emulating fresh DUT)	0 $\Omega$
$R_{ext}$ (emulating aged DUT)	15 m $\Omega$ , 18.75 m $\Omega$ , and 25 m $\Omega$
$T_1$	2 $\mu$ s
$T_2$	3 $\mu$ s
MCU	TMS320F280049C

the proposed method. The MOSFETs used in the experiment are STW58N60DM2AG, FQA28N15, C3M120090D, and IMW120R350M1H, of which on-state resistances are 52 m $\Omega$ , 67 m $\Omega$ , 120 m $\Omega$ , and 350 m $\Omega$ , respectively [32]-[35]. The specifications of the circuit components are shown in Table II.

## B. SOFTWARE SETUP

Assuming  $T_1$ ,  $T_2$ , and  $L$  are fixed,  $R$  depends on  $\Delta i_L[k]$  and  $V_g$  in (14). Calculating  $R$  using (14) contains exponential and logarithmic operations which require considerable resource of the MCU. For simpler and quicker calculation, curve fitting technique is used to express  $R$  as a polynomial of two variables,  $\Delta i_L[k]$  and  $V_g$ .

The range of  $V_g$  is set to the operating window for PCS and the boundary of  $\Delta i_L$  is defined as the value that can be varied by  $V_g$ . The maximum  $\Delta i_L$  is expressed as in (16).

$$\Delta i_{L\_max} = (T_2 - T_1) \frac{V_{g\_min}}{L} \quad (16)$$

In (16),  $V_{g\_min}$  represents minimum of  $V_g$  and  $\Delta i_{L\_max}$  means maximum  $\Delta i_L$  that corresponds to zero  $R$  in (14) when  $V_g$  in Fig. 7(a) is  $V_{g\_min}$ . If  $\Delta i_L > \Delta i_{L\_max}$  and  $V_g = V_{g\_min}$ ,  $R$  becomes negative or imaginary in (14), which has little meaning. Black dots in Fig. 8 are the calculated  $R$  using (14) by sweeping  $V_g$  from 10 to 15 V and  $\Delta i_L$  0.5 to 1 A. Setting the approximated  $R$  or  $R'$  is a third-order function of  $\Delta i_L$  and  $V_g$  as in (17), the surface in Fig. 8 represents  $R'$ .

$$\begin{aligned} R' = f(V_g, \Delta i_L) = & p_{00} + p_{10}V_g + p_{01}\Delta i_L \\ & + p_{20}V_g^2 + p_{11}V_g\Delta i_L + p_{02}\Delta i_L^2 \\ & + p_{30}V_g^3 + p_{21}V_g^2\Delta i_L + p_{12}V_g\Delta i_L^2 + p_{03}\Delta i_L^3 \end{aligned} \quad (17)$$

In (17),  $p_{ij}$  ( $i = 0, 1, 2, \text{ or } 3; j = 0, 1, 2, \text{ or } 3$ ) is a coefficient of the term  $V_g^i \Delta i_L^j$  which were generated by the multivariate polynomial function of MATLAB curve-fitting tool [36]. The curve-fitting tool calculates  $p_{ij}$  by fitting (17) to the black dots in Fig. 8 using the least-squares method. The fitted  $p_{ij}$ 's are in Table III. The error  $R - R'$  is plotted in Fig. 9. It is verified that

the error between  $R$  calculated by (14) and  $R'$  calculated by (17) is less than 2 m $\Omega$  of which effect on sensing the increase of  $R_{DUT}$  is negligible. Equation (17) is used as  $f(V_g, \Delta i_L)$ , shown in Fig. 7(a). Using the higher order terms of  $\Delta i_L$  and  $V_g$ , yields the smaller  $R - R'$  in Fig. 9, while it requires more computational resource of MCU as a trade-off.

The analog-to-digital converters (ADCs) in the MCU convert  $i_L(T_1)$  and  $i_L(T_2)$  into digital bits. Variables ADC\_VRT1, ADC\_VRT2, and ADC\_DeII in the MCU contain the data converted from  $v_R(kT_S + T_1)$ , and  $v_R(kT_S + T_2)$ , and  $\Delta i_L[k]$ , respectively. Sensing gain is decided as  $2^{12}/3.3 = 1241$  since the ADCs are 12 bits and powered by 3.3-V voltage source. Equation (18) shows the relationship between the physical quantities and variables in the MCU.

$$\text{ADC\_VRT1} = 1241 \cdot v_R(kT_S + T_1) \quad (18a)$$

$$\text{ADC\_VRT2} = 1241 \cdot v_R(kT_S + T_2) \quad (18b)$$

$$\begin{aligned} \text{ADC\_DeII} &= 1241 \cdot \Delta i_L[k] \\ &= \left( \frac{\text{ADC\_VRT2} - \text{ADC\_VRT1}}{R_{shunt}} \right) \end{aligned} \quad (18c)$$

A portion of the C code programmed in the MCU to realize the proposed method is shown in Table IV. Literal  $V_{g\_gain}$  in

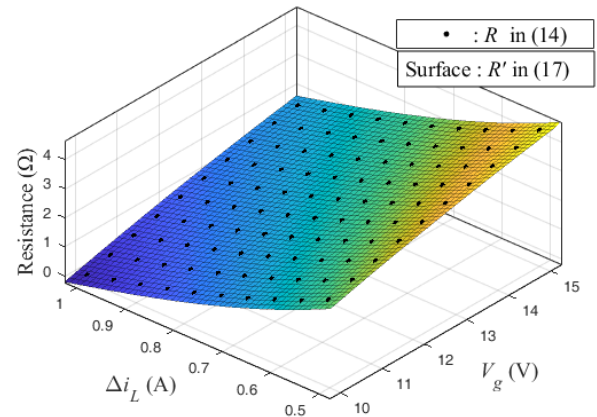


FIGURE 8.  $R$  plotted as function of  $V_g$  and  $\Delta i_L$ .

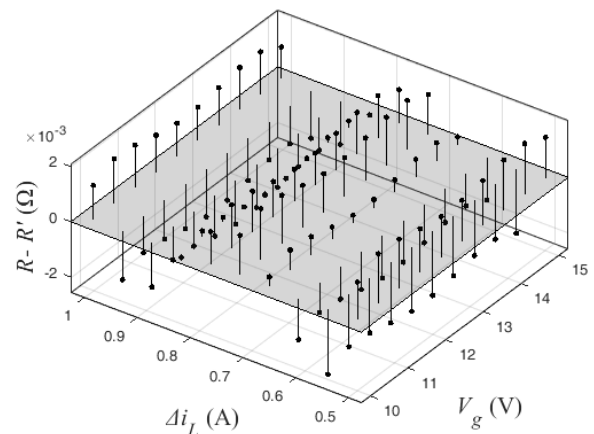


FIGURE 9. Resistance error as function of  $V_g$  and  $\Delta i_L$ .

TABLE III COEFFICIENTS OF FITTED FUNCTION

Parameter	Description
$p_{00}$	2.211
$p_{10}$	0.9838
$p_{01}$	-16.94
$p_{20}$	-0.03922
$p_{11}$	-0.01832
$p_{02}$	11.79
$P_{30}$	0.0006949
$p_{21}$	0.0002357
$p_{12}$	0.004273
$p_{03}$	-3.552

TABLE IV. C CODE TO REALIZE THE PROPOSED METHOD

Function	C Code
$\Delta i_L[k]$	ADC_DeI = abs(ADC_VRT2 - ADC_VRT1)*(1/R_shunt); DeI = ADC_DeI*(1/1241);
$V_g$	$V_g = \text{ADC\_Vg} * V_{g\_gain} * 0.0008058;$
$R$	$R = p_{00} + p_{10} * V_g + p_{01} * \text{DeI} + p_{20} * V_g * V_g$ $+ p_{11} * V_g * \text{DeI} + p_{02} * \text{DeI} * \text{DeI}$ $+ p_{30} * V_g * V_g * V_g + p_{21} * V_g * V_g * \text{DeI}$ $+ p_{12} * V_g * \text{DeI} * \text{DeI} + p_{03} * \text{DeI} * \text{DeI} * \text{DeI};$

Table IV is a parameter to compensate the gain of the voltage sensor shown in Fig. 7(a). Division by 1241 was rephased by multiplying 0.0008058 to reduce computation time in MCU. The proposed method calculates  $R'$  through the ADC interrupt service routine (ISR) in the MCU, and the time taken by the ISR was less than 2  $\mu\text{s}$ . This means that the time taken to calculate  $R'$  is less than 2  $\mu\text{s}$ .

### C. RESULTS AND DISCUSSION

The proposed method is verified by comparing the calculated  $R'$  by the MCU with zero, 15-m $\Omega$ , 18.75-m $\Omega$ , or 25-m $\Omega$   $R_{ext}$ . Fig. 10 illustrates the experimental waveforms. Magenta, blue, and green waveforms represent  $i_L$  (3 A/div.),  $v_g$  (10 V/div.), and  $v_R$  (900 mV/div.), respectively. In Fig. 10,  $i_L$  at the top was measured by a 50-MHz bandwidth current probe CP030 manufactured by LeCroy [37]. The waveform is free of noise compared to the waveform of  $v_{sen}$  in Fig. 3. As indicated in the  $v_R$  waveform in Fig. 10, the MCU measures  $v_R$  twice, i.e., the ADCs convert  $v_R$  at the instant 2  $\mu\text{s}$  and 3  $\mu\text{s}$  after the rise of  $v_{gs}$ . No ringing or oscillation in  $v_R$  at these instants proves the noise-robustness of the proposed method.

Figs. 11, 12, and 13 illustrate  $R'$  calculated by the code shown in Table IV programmed in the MCU when the DUT is STW58N60DM2AG. The x-axis represents the number of sensing  $v_R$ . The values of  $R'$  were monitored online, or while the circuit in Fig. 7(a) is operating, by utilizing Texas

Instruments' code composer studio. Green markers in Fig. 11, orange in Fig. 12, and red in Fig. 13 represent the measured  $R'$  when  $R_{ext} = 15, 18.75, \text{ or } 25 \text{ m}\Omega$ , respectively. Blue markers in Figs. 11, 12, and 13 are when  $R_{ext} = 0$ . Fig. 14 shows a boxplot of  $R'$  when  $R_{ext} = 0, 15 \text{ m}\Omega, 18.75 \text{ m}\Omega, \text{ or } 25 \text{ m}\Omega$ , demonstrating that the measured  $R'$  increases as  $R_{ext}$  increases. Fig. 15 compares the average  $R'$ s shown in the boxplot in Fig. 14 which are 0.8597  $\Omega$ , 0.8745  $\Omega$ , 0.8782  $\Omega$ , and 0.8845  $\Omega$  when  $R_{ext} = 0, 15 \text{ m}\Omega, 18.75 \text{ m}\Omega, \text{ and } 25 \text{ m}\Omega$ , respectively. Fig. 16 shows the increments of  $R'$  and  $R_{ext}$  were highly similar to each other though the absolute values of  $R'$  and  $R_{ext}$  were not same to each other. The 14.8-m $\Omega$ , 18.49-m $\Omega$ , and 24.8-m $\Omega$  increase in  $R'$  corresponds to 15-m $\Omega$ , 18.75-m $\Omega$ , and 25-m $\Omega$  increase in  $R_{ext}$ , respectively. The accuracy of measuring the increase of the on-state resistance is therefore 98.6%, 98.6%, and 99.2%.

MOSFETs  $Q$  and DUT in Fig. 7(a) are varied to further verify the effectiveness of the proposed method. Figs. 17, 18, and 19 show calculated  $R'$  by MCU when  $Q$  and the DUT is FQA28N15, C3M120090D, and IMW120R350M1H, respectively. Black markers in Fig. 17, purple in Fig. 18, and pink in Fig. 19 represent the measured  $R'$  when  $R_{ext} = 0$ . Green markers in Fig. 17, brown in Fig. 18, and cyan in Fig. 19 represent the measured  $R'$  when  $R_{ext} = 15 \text{ m}\Omega$ . Figs 17, 18, and 19 demonstrate that  $R'$  increases as  $R_{ext}$  increases, and for a more visual representation,  $R'$  data is depicted as a boxplot in Fig. 20. The boxplot shows that there is a noticeable increase in  $R'$  when  $R_{ext} = 15 \text{ m}\Omega$ . Fig. 21 shows the average values of Figs. 17, 18, and 19, where Fig. 21(a) and Fig. 21(b) are for  $R_{ext} = 0$  or 15 m $\Omega$ , respectively. In Fig. 21(a), the average  $R'$  values are 0.9037  $\Omega$ , 0.9944  $\Omega$ , and 1.688  $\Omega$  when the DUT is FQA28N15, C3M120090D, or IMW120R350M1H, respectively. The corresponding average  $R'$  values are 0.9194  $\Omega$ , 1.0102  $\Omega$ , and 1.7028  $\Omega$  in Fig. 21(b). Fig. 22 shows the difference in average  $R'$  before and after the addition of  $R_{ext}$ . The increased  $R'$  values when DUT is FQA28N15, C3M120090D, or IMW120R350M1H are determined 15.66 m $\Omega$ , 15.71 m $\Omega$ , and 14.82 m $\Omega$ , respectively, with accuracies of 95.8%, 95.5%, and 98.8%, respectively.

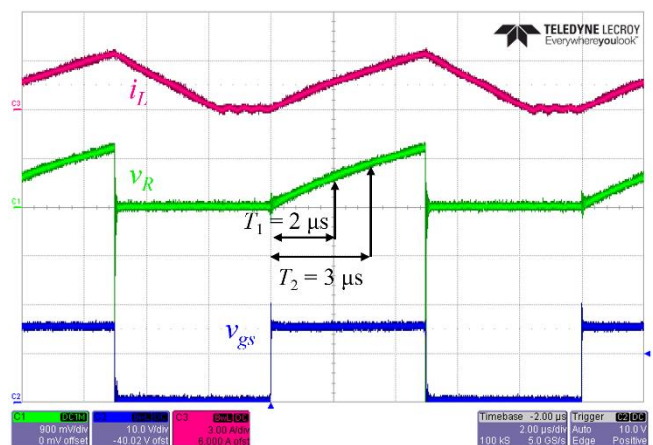


FIGURE 10. Experimental waveforms



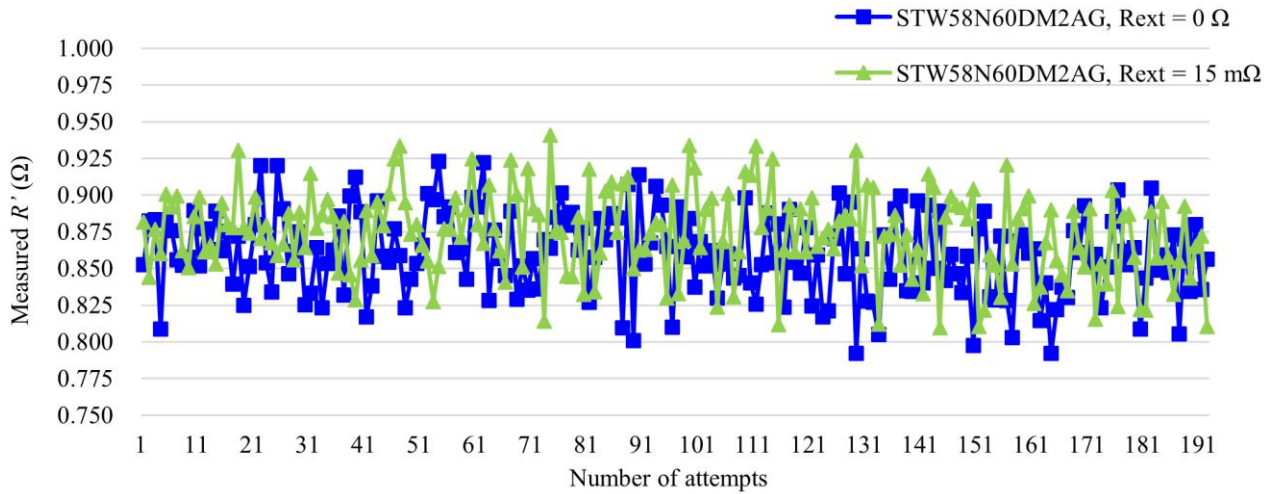


FIGURE 11. Experimental results when the DUT is STW58N60DM2AG and  $R_{ext} = 0$  or  $15 \text{ m}\Omega$ .

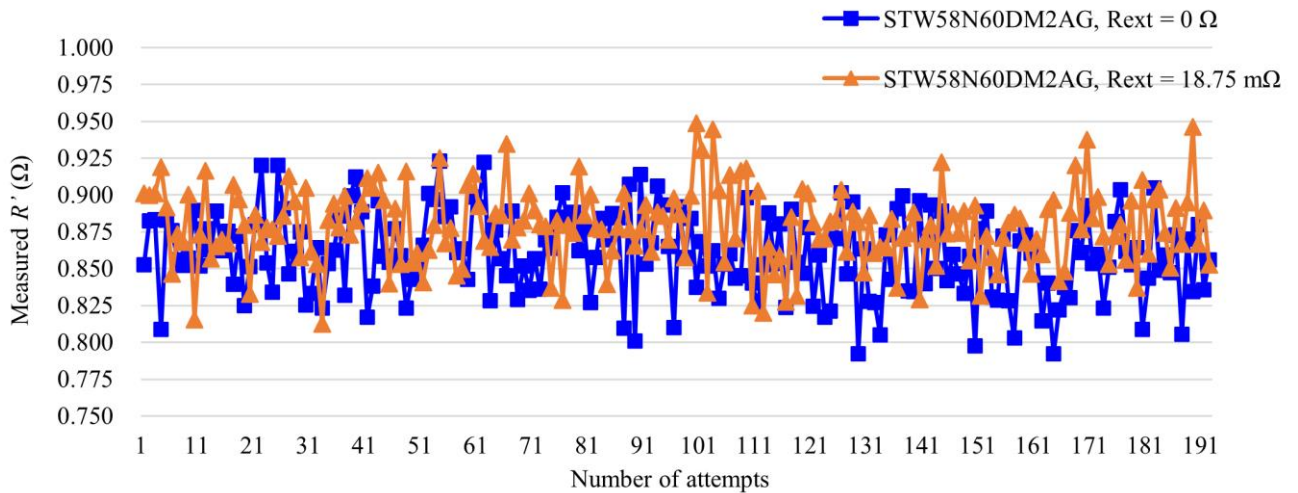


FIGURE 12. Experimental results when the DUT is STW58N60DM2AG and  $R_{ext} = 0$  or  $18.75 \text{ m}\Omega$ .

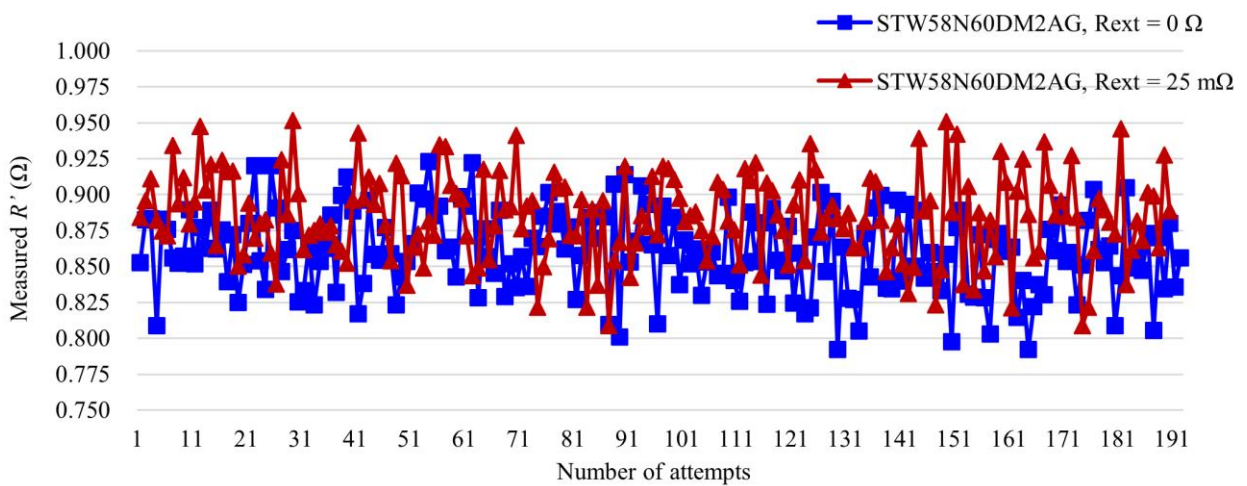


FIGURE 13. Experimental results when the DUT is STW58N60DM2AG and  $R_{ext} = 0$  or  $25 \text{ m}\Omega$ .

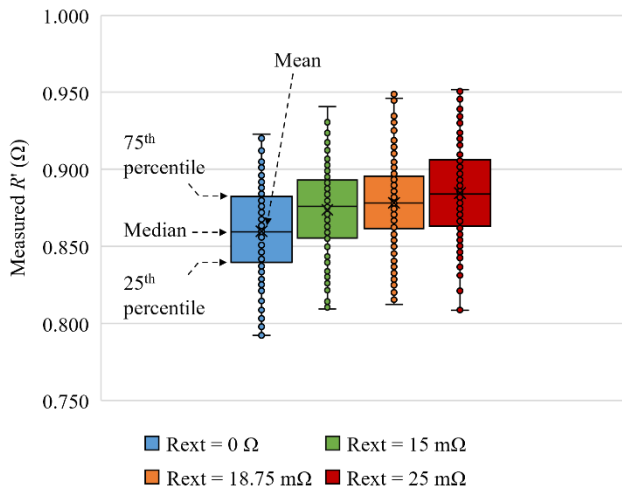


FIGURE 14. Boxplot of  $R'$  when  $R_{ext} = 0, 15, 18.75,$  or  $25$  mΩ.

## V. CONCLUSION

A method for online measuring on-state resistance to estimate the RUL of a power semiconductor device has been proposed. The proposed method does not measure the noisy on-state voltage of power semiconductor device like conventional OVMCs, which increases the accuracy of the measurement and simplifies the sensing circuit. The proposed method accurately measures the increase of  $R_{DUT}$  by sensing noise-robust quantities such as inductor current and DC voltage and inductor current. The proposed method also requires no additional filters and arithmetic circuits for simple implementation.

Motivated by the fact that the increased  $R_{DUT}$  by aging also increases the equivalent resistance of the PWM converter while DUT is ON, the converter is modeled into the equivalent resistance-inductance (RL) circuit with a series-connected voltage source. The proposed method samples the inductor current twice in a single switching period, and the difference between the two sampled values are utilized to estimate the

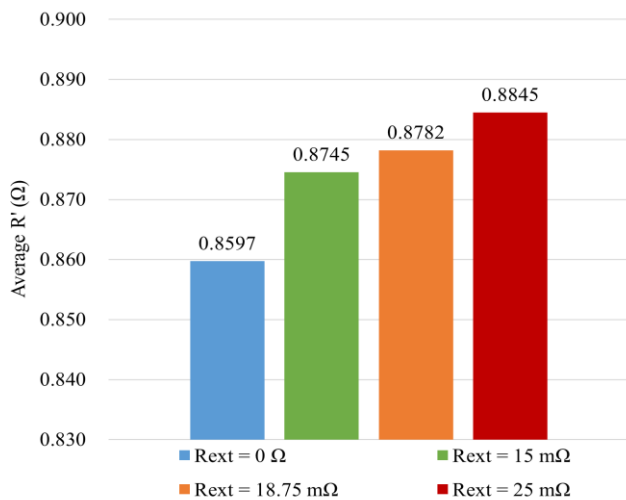


FIGURE 15. Average  $R'$  of experimental results shown in Figs. 11-14.

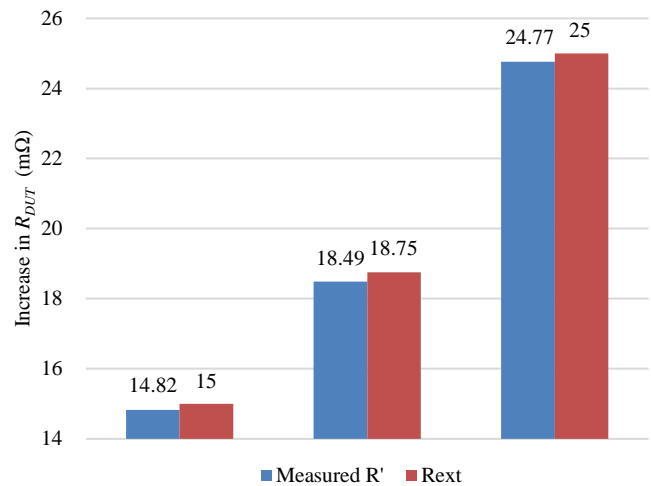


FIGURE 16. Comparison of the difference between measured  $R'$  and  $R_{ext}$ .

equivalent resistance of the RL circuit. A third-order polynomial was derived by curve fitting the simulated resistances for various inductor current differences and voltages. The proposed method allows the MCU to calculate the increased resistance, which in turn allows the MCU to determine the expiration of the MOSFET on its own.

The concept of the proposed online on-state resistance measurement was applied to the prototype non-inverting buck-boost converter. The increase of the on-state resistance of a MOSFET by aging in the prototype converter was emulated by an extra series-connected 15-mΩ, 18.75-mΩ, or 25-mΩ resistor. The resistance increase by these resistors were measured 14.8 mΩ (98.6% accuracy), 18.49 mΩ (98.6% accuracy), and 24.8 mΩ (99.2% accuracy), respectively.

The proposed method was verified on various MOSFETs. Various MOSFETs were applied to the prototype converter to observe the increase in resistance before and after an extra series-connected 15-mΩ resistor was attached. The resistance increased by 15-mΩ resistor was obtained 15.66 mΩ (95.8% accuracy), 15.71 mΩ (95.5% accuracy), and 14.82 mΩ (98.8% accuracy) when DUT is FQA28N15, C3M120090D, and IMW120R350M1H, respectively. The proposed method showed at least 95.5% accurate on a variety of MOSFETs. The MOSFET was judged to be expired if the resistance increase measured by the proposed method is higher than 20% of the initial on-state resistance of MOSFET. This proves the feasibility of the proposed method to estimate the RUL of the MOSFETs.

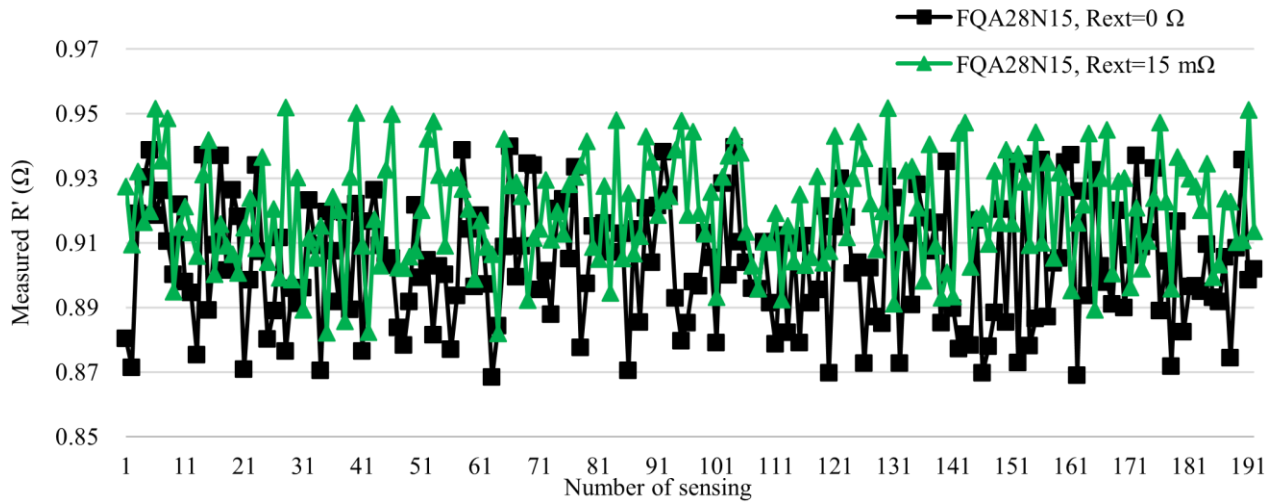


FIGURE 17. Experimental results when the DUT is FQA28N15 and  $R_{ext} = 0$  or 25 m $\Omega$ .

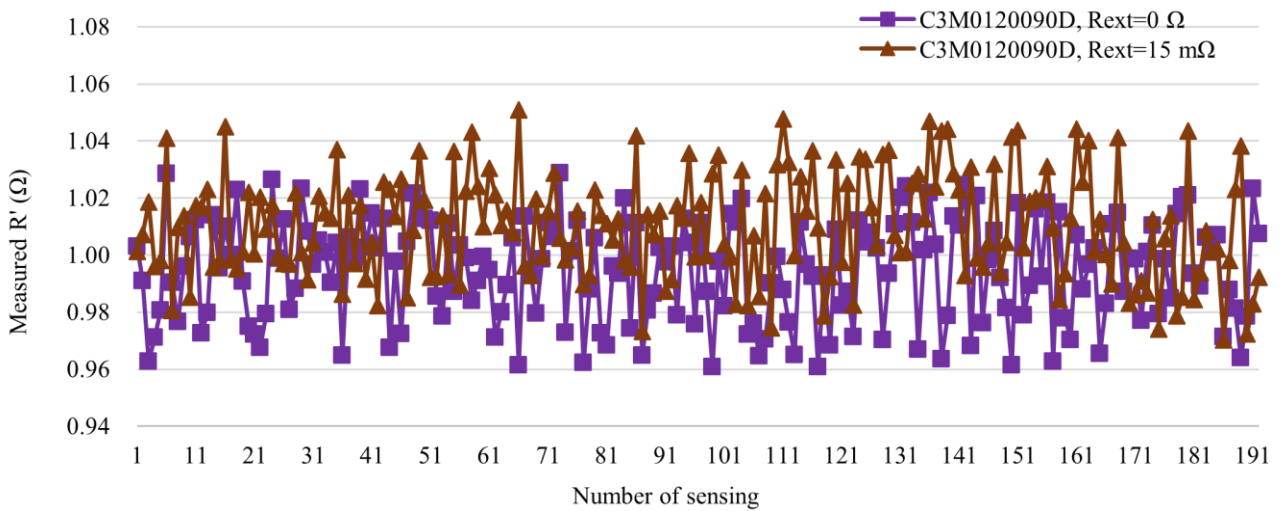


FIGURE 18. Experimental results when the DUT is C3M120090D and  $R_{ext} = 0$  or 25 m $\Omega$ .

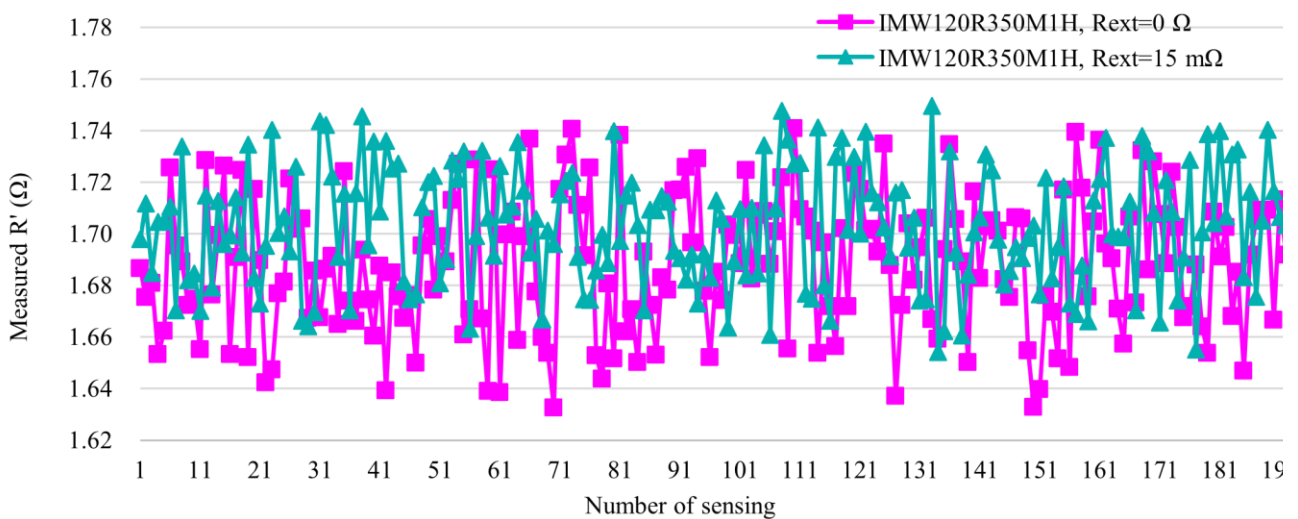


FIGURE 19. Experimental results when the DUT is IMW120R350M1H and  $R_{ext} = 0$  or 25 m $\Omega$ .

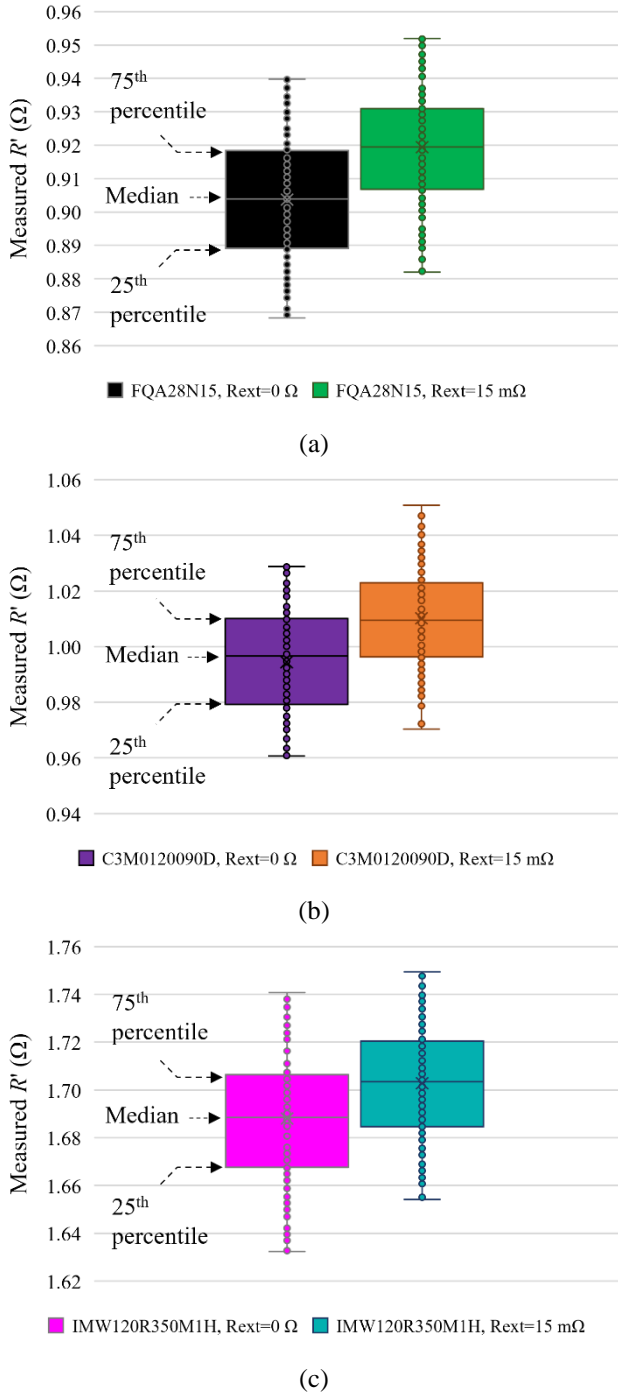


FIGURE 20. Boxplot of  $R'$  when  $R_{ext} = 0$  or  $15 \text{ m}\Omega$  and DUT is (a) FQA28N15, (b) C3M0120090D, or (c) IMW120R350M1H.

## APPENDIX

If a current sensor is utilized instead of  $R_{shunt}$  in Fig. 6, its bandwidth should be higher than 9 times the switching frequency. Fourier series expression of  $i_L$  is in (19).

$$i_L(t) = a_0 + \sum_{n=1}^{\infty} (a_n \sin(2\pi f_0 n t) + b_n \cos(2\pi f_0 n t)) \quad (19)$$

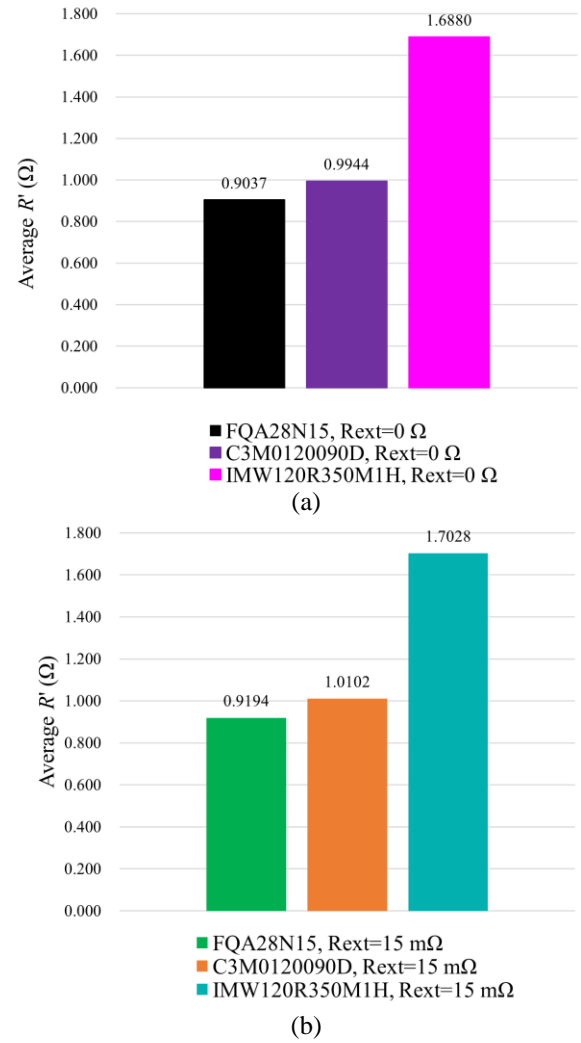


FIGURE 21. Average  $R'$  of experimental results shown in Figs. 17-19 when  $R_{ext} =$  (a) 0 or (b)  $15 \text{ m}\Omega$ .

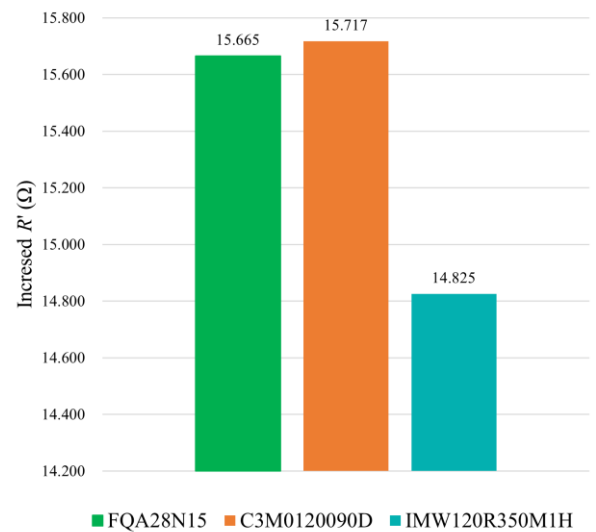


FIGURE 22. Increased resistance when adding an extra series-connected  $15\text{-m}\Omega$  resistor for each device.



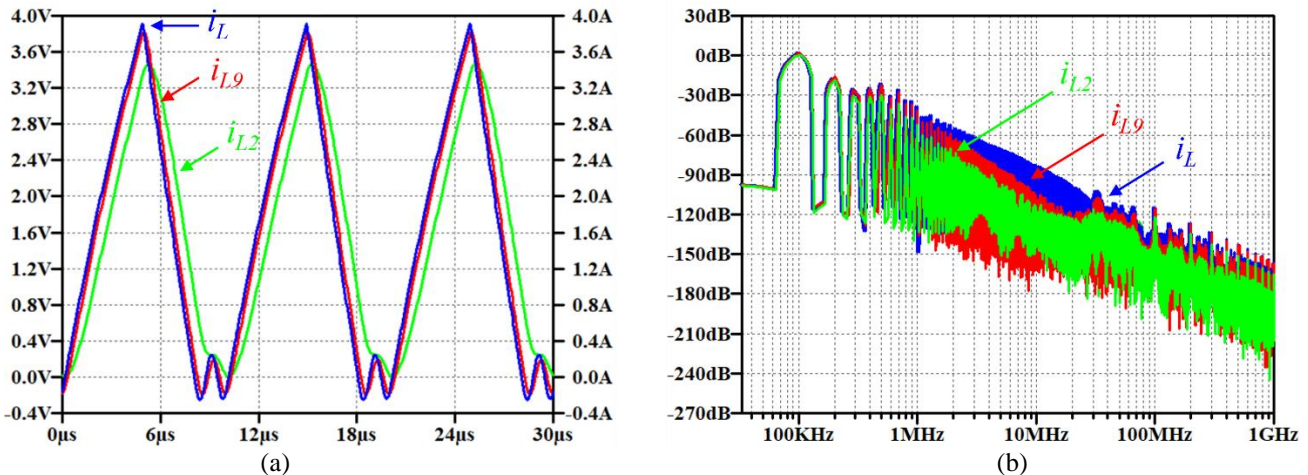


FIGURE 23. (a) Original and sensed  $i_L$  waveforms and (b) their FFT results.

In (19),  $a_0$  and  $f_0$  are the DC component and fundamental frequency of  $i_L$ . Coefficients  $a_n$  and  $b_n$  represent the Fourier coefficients of the  $n$ -th harmonic. In Fig. 23(a), blue waveform is the original waveform of  $i_L$ . Green waveform  $i_{L2}$  and red waveform  $i_{L9}$  depict the sensed  $i_L$  when its bandwidth is set to twice and nine times  $f_0$ , respectively. The wider bandwidth guarantees the less distortion and delay in the sensed  $i_L$ . Fig. 23(b) shows the fast Fourier transform (FFT) of the waveforms in Fig. 23(a). The green waveform with the twice  $f_0$  bandwidth shows more distortion in the high frequency region than the red waveform with nine times  $f_0$  bandwidth. These distortions can increase the error between the original and sensed  $i_L$  and lowers the accuracy of estimating RUL.

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**JUNHO SHIN** received the B.S. degree in energy system engineering from Chung-ang University, Seoul, South Korea, in 2022, where he is currently working toward the M.S. degree with the Department of Smart Cities. His research interests include dc-dc converter, power conversion system and its control, and reliability of power semiconductors.



**JONG-WON SHIN** (Member, IEEE) received the B.S. and Ph.D. degrees in electrical engineering from Seoul National University, Seoul, South Korea, in 2006 and 2013, respectively. From 2013 to 2015, he was a Postdoctoral Researcher with Virginia Tech, Blacksburg, VA, USA. From 2015 to 2018, he was a Senior Scientist with the Electronics Research Department, Toyota Research Institute of North America, Ann Arbor, MI, USA. He worked in Chung-Ang University, Seoul, Korea, as an Assistant Professor from 2018 to 2022 and as an Associate Professor from 2022 to 2024. He joined Seoul National University, Seoul, Korea, in 2024, where he is currently an Assistant Professor. From 2021 to 2024, he was also a Visiting Associate Professor with Nagoya University, Nagoya, Japan. His research interests include power conversion, energy management, and power semiconductor packaging.



**Wonhee Kim** (Member, IEEE) received the B.S. and M.S. degrees in electrical and computer engineering and the Ph.D. degree in electrical engineering from Hanyang University, Seoul, South Korea, in 2003, 2005, and 2012, respectively. From 2005 to 2007, he was with Samsung Electronics Company, Suwon, South Korea. In 2012, he was with the Power and Industrial Systems Research and Development Center, Hyosung Corporation, Seoul. In 2013, he was a Post-Doctoral Researcher with the Institute of Nano Science and Technology, Hanyang University, and a Visiting Scholar with the Department of Mechanical Engineering, University of California at Berkeley, Berkeley, CA, USA. From 2014 to 2016, he was with the Department of Electrical Engineering, Dong-A University, Busan, South Korea. He is currently a Professor with the School of Energy Systems Engineering, Chung-Ang University, Seoul. His current research interests include nonlinear control and nonlinear observers, and their industrial applications. He has served as an Associate Editor for IEEE/ASME TRANSACTIONS ON MECHATRONICS, IEEE ACCESS, and the Journal of Electrical Engineering & Technology.